



## UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Address: COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandra, Virginia 22313-1450 www.uspko.gov

Γ	APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
	09/936,040	12/11/2001	Ichio Yudasaka	110554	7811
	7:	590 06/27/2003			
Oliff & Berridge				EXAMINER	
	PO Box 19928 Alexandria, VA 22320			SEFER, AHMED N	
				ART UNIT	PAPER NUMBER
				2826	
			DATE MAILED: 06/27/2003		

Please find below and/or attached an Office communication concerning this application or proceeding.

Applicati n N . Applicant(s)  Og/936,040 HIRAKATA ET AL.  Office Action Summary  Examiner Art Unit	/					
Office Action Summany						
Office Action Summary						
Examiner Action Summary Examiner						
A. Sefer 2826						
The MAILING DATE of this communication appears n the cover sheet with the correspondence address P riod for Reply						
A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) FROM THE MAILING DATE OF THIS COMMUNICATION.  - Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.  - If the period for reply specified above is less than thirty (30) days, a reply within the statutory minimum of thirty (30) days will be considered timely.  - If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.  - Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133).  - Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).  Status						
1) Responsive to communication(s) filed on 23 April 2003.						
2a) This action is <b>FINAL</b> . 2b) This action is non-final.						
3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is						
closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213. <b>Disposition of Claims</b>						
4)⊠ Claim(s) <u>1-19</u> is/are pending in the application.						
4a) Of the above claim(s) <u>8-12 and 18</u> is/are withdrawn from consideration.						
5)⊠ Claim(s) <u>1-7 and 13-17</u> is/are allowed.						
6)⊠ Claim(s) <u>19</u> is/are rejected.	NATHAN J. FLYNN					
7) Claim(s) is/are objected to. SUPERVISORY PATENT EXAMINER						
8) Claim(s) are subject to restriction and/or election requirement. TECHNOLOGY CENTER 2800						
Application Papers						
9) The specification is objected to by the Examiner.						
10) The drawing(s) filed on is/are: a) accepted or b) objected to by the Examiner.						
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).  11) The proposed drawing correction filed on is: a) approved b) disapproved by the Examiner.						
If approved, corrected drawings are required in reply to this Office action.						
12) The oath or declaration is objected to by the Examiner.						
Priority under 35 U.S.C. §§ 119 and 120						
13)⊠ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).						
a) ☐ All b) ☐ Some * c) ☐ None of:						
1. Certified copies of the priority documents have been received.						
2. Certified copies of the priority documents have been received in Application No						
3. Copies of the certified copies of the priority documents have been received in this National Stage						
application from the International Bureau (PCT Rule 17.2(a)).  * See the attached detailed Office action for a list of the certified copies not received.						
14) Acknowledgment is made of a claim for domestic priority under 35 U.S.C. § 119(e) (to a provisional application).						
a) ☐ The translation of the foreign language provisional application has been received.  15) ☐ Acknowledgment is made of a claim for domestic priority under 35 U.S.C. §§ 120 and/or 121.						
Attachment(s)						
1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO-1449) Paper No(s)						

## **DETAILED ACTION**

## Response to Amendment

1. Examiner acknowledges that the instant application benefits from a British Patent Application No. 0000376.4 with a filing date of 1/7/2000 and that Akimo US Patent No. 6,480,179 is not available as a prior art.

## Claim Rejections - 35 USC § 102

- 2. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:
  - A person shall be entitled to a patent unless -
  - (b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.
- 3. Claim 19 is rejected under 35 U.S.C. 102(b) as being anticipated by Kawachi et al. (JP 64-25573).

Kawachi et al disclose in fig. 1 a thin film transistor, comprising a channel region facing a gate electrode 3 through a gate insulating film 2, the channel region having a partially distorted portion 10 distorted in a thickness direction of the channel region; source and drain regions 5/4 connection to the channel region in a semiconductor film in contact with a surface of an insulating substrate; and a recombination center formed around the partially distorted portion, the recombination center having a relatively low degree of crystallization among crystal semiconductor films forming the channel region.

Application/Control Number: 09/936,040

Art Unit: 2826

Allowable Subject Matter

Page 3

4. Claims 1-7 and 13-17 are allowed.

5. The following is a statement of reasons for the indication of allowable subject matter:

The prior art fails to disclose the device structure as recited in claims 1 and 17. Specifically, the

references of record do not teach or make obvious a TFT with a deformed channel region, which

extends through a gate insulating film.

Any inquiry concerning this communication or earlier communications from the

examiner should be directed to A. Sefer whose telephone number is (703) 605-1227.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's

supervisor, Nathan Flynn can be reached on (703) 308-6601.

**ANS** 

June 20, 2003

. . . . . . .